

Electronic Supplementary Information

Efficient Conversion of CO₂ and H₂O into Hydrocarbon Fuel over ZnAl₂O₄-Modified Mesoporous ZnGaNO under Visible Light Irradiation[†]

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Experimental Section

Material preparation. A starting reagent, NaGaO₂ powder, was synthesized by heating a stoichiometric mixture of Na₂CO₃ and Ga₂O₃ at 850 °C for 12 h. The mixture of as-prepared NaGaO₂ and commercial NaAlO₂ (China National Medicines Corp. Ltd.) was dispersed in de-ionized water to form a colloidal suspension, magnetically stirred for 2h, and then, dried at 80 °C for 5h to get a gel. The gel was heated at 900 °C for 12 h for obtaining the NaGa_{1-x}Al_xO₂ solid solution.

To synthesize the mesoporous Zn(Ga_{1-x}Al_x)₂O₄, the NaGa_{1-x}Al_xO₂ colloidal suspension (0.2 M, 10 mL) was added into an aquatic solution of Zn(CH₃COO)₂ (0.05 M, 20 mL), stirred for 2 h at room temperature. The above-mentioned mixture was further heated in a 40 mL of Teflon-lined hydrothermal autoclave at 200 °C for 5 h for improving the crystallinity of Zn(Ga_{1-x}Al_x)₂O₄. The production was washed with de-ionized water, centrifuged and dried at 60 °C for 2 h, followed by nitriding it into ZnAl₂O₄-modified ZnGaNO solid solutions using a tubular furnace with an inner diameter of 50 mm at 700 °C for 5 h with an NH₃ flowing rate of 250 mLmin⁻¹. In addition, the mesoporous ZnGa₂O₄ was synthesized by ion exchange of NaGaO₂ and Zn(CH₃COO)₂ using the similar procedure to Zn(Ga_{1-x}Al_x)₂O₄, and then nitriding it into ZnGaNO solid solution using the similar route to ZnAl₂O₄-modified ZnGaNO.

Sample characterization. Crystal phases of these samples were determined using an X-ray diffractometer (XRD, Rigaku Ultima III, Japan) operated at 40 kV and 40 mA using Cu K α radiation. The diffuse reflectance spectra were recorded using a UV-Vis spectrophotometer (UV-2500, Shimadzu Co., Japan) and transformed to the absorption spectra according to the Kubelka-Munk relationship. The morphology was observed by using a transmission electron microscope (TEM, FEI Tecnai G2 F30 S-Twin, USA). Nitrogen absorption-adsorption isotherms were measured at 77 K on a Micromeritics ASAP 2000 volumetric adsorption analyzer. Before the measurements, the samples were pretreated at 200 °C for 2 h under flowing N₂ gas for clearing the surface. The BET specific surface areas were calculated using adsorption data acquired at a relative pressure (P/P₀) range of 0.05-0.15. The pore size distribution curves were calculated from the analysis of the adsorption branch of the isotherm using the Barrett-Joyner-Halenda (BJH) algorithm. The X-ray photoelectron spectroscopy (XPS) was obtained on PHI5000 Versa Probe (ULVAC-PHI, Japan) with monochromatized Al K α x-ray radiation (1486.6 eV). The energy resolution of the electrons analyzed by the hemi-spherical mirror analyzer is about 0.2 eV. The binding energy was determined by reference to the C 1s line at 284.8 eV.

Photoreduction of CO₂. Pt cocatalyst was loaded on the catalyst surface by illuminating an aqueous CH₃OH solution (the volume ratio of CH₃OH to H₂O is 0.2) of H₂PtCl₆·6H₂O for about 10 h. The weight ratio of Pt to catalyst was 0.5 wt. %. In the photocatalytic reduction of CO₂, ZnAl₂O₄-modified ZnGaNO powder (0.1 g) was uniformly dispersed on a glass reactor with an area of 4.2 cm². The light irradiation system contains a 300 W Xe-lamp with cut-off filter L42 to achieve visible light ($\lambda \geq 420$ nm). The volume of the reaction system was about 230 mL. The reaction setup was vacuum-treated several times, and then, high purity CO₂ gas was introduced into the reaction to achieve ambient pressure. De-ionized water (0.4 mL) was injected into the reaction system as the

reducing agent. During irradiation, about 1 mL of gas was taken from the reaction cell at given intervals for subsequent CH₄ concentration analysis using a gas chromatograph (GC-2014; Shimadzu Corp., Japan).

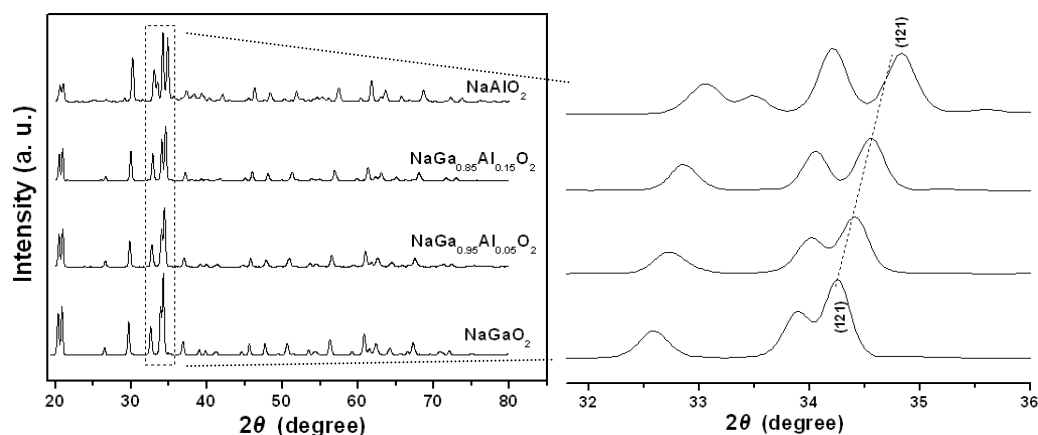


Fig. S1 XRD patterns for NaGaO_2 powder (JCPDS No 76-2151), $\text{NaGa}_{1-x}\text{Al}_x\text{O}_2$ ($x=0.05, 0.15$), and NaAlO_2 (JCPDS No 33-1200). Inset shows the diffraction peak position change of the (121) plane of the $\text{NaGa}_{1-x}\text{Al}_x\text{O}_2$. The peak position gradually shifted into the higher 2θ value with an increase in x value from 0 to 1 because the ion radius of Al^{3+} ($0.57\text{\AA}$) is smaller than that of Ga^{3+} ($0.62\text{\AA}$), indicating that the $\text{NaGa}_{1-x}\text{Al}_x\text{O}_2$ solid solution formed by calcining the mixed gel of NaGaO_2 and NaAlO_2 .

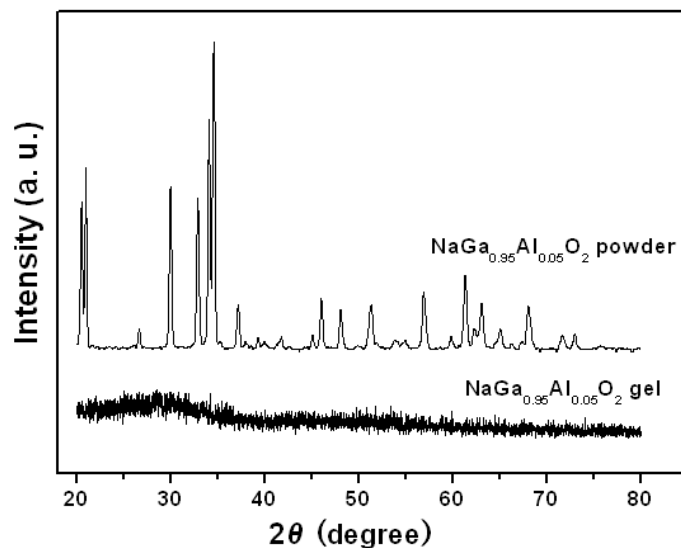


Fig. S2 XRD patterns for $\text{NaGa}_{0.95}\text{Al}_{0.05}\text{O}_2$ powder and gel.

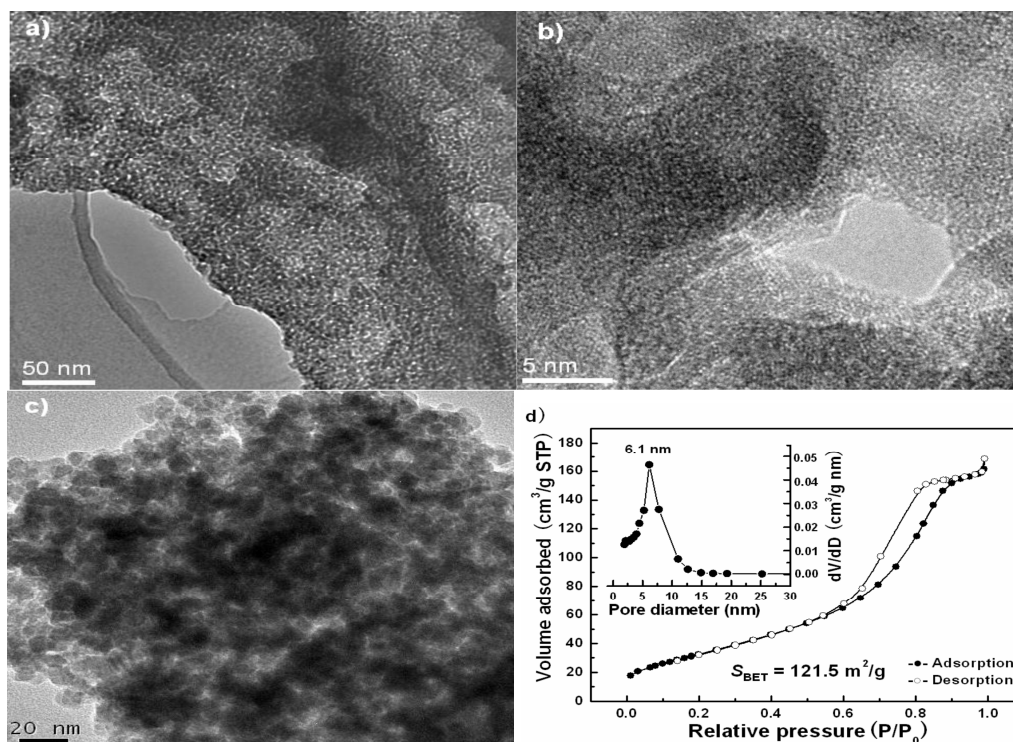


Fig.S3. a) TEM image for NaGa_{1-x}Al_xO₂ (x=0.05) colloidal particles. b) High-magnification TEM image of a typical mesopore in the NaGa_{1-x}Al_xO₂ (x=0.05) colloidal particles. c) TEM image of Zn(Ga_{1-x}Al_x)₂O₄ (x=0.05). d) Nitrogen absorption-desorption isotherms and pore-size distribution (inset) for Zn(Ga_{1-x}Al_x)₂O₄ (x=0.05).

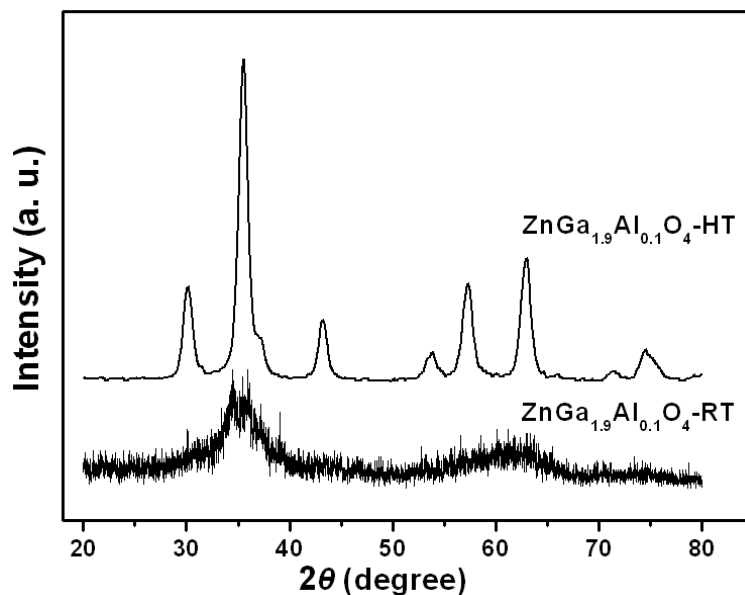


Fig. S4 XRD patterns for ZnGa_{1.9}Al_{0.1}O₄ obtained by room-temperature ion exchange (denoted as ZnGa_{1.9}Al_{0.1}O₄-RT) and hydrothermal treatment of ZnGa_{1.9}Al_{0.1}O₄-RT (denoted as ZnGa_{1.9}Al_{0.1}O₄-HT).

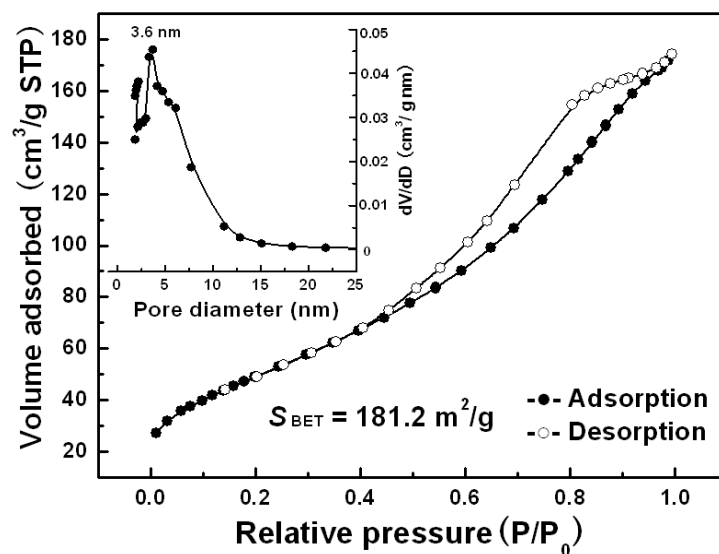


Fig. S5 Nitrogen absorption-desorption isotherms and pore-size distribution (inset) for $\text{ZnGa}_{1.9}\text{Al}_{0.1}\text{O}_4$ obtained by room-temperature ion exchange.

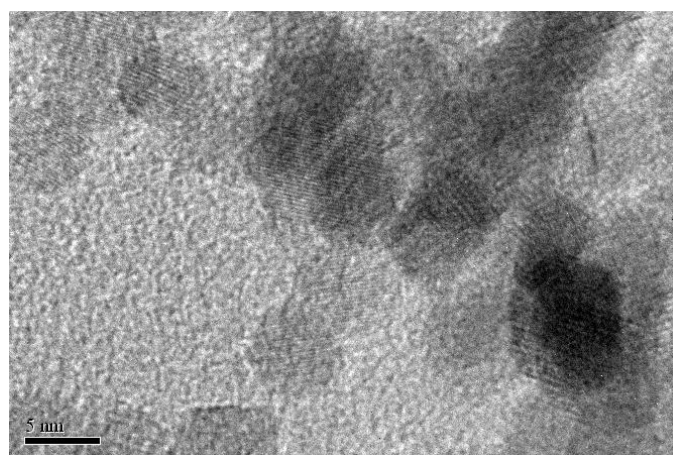


Fig. S6 HR-TEM image of $\text{ZnGa}_{1.9}\text{Al}_{0.1}\text{O}_4$ obtained by hydrothermal treatment

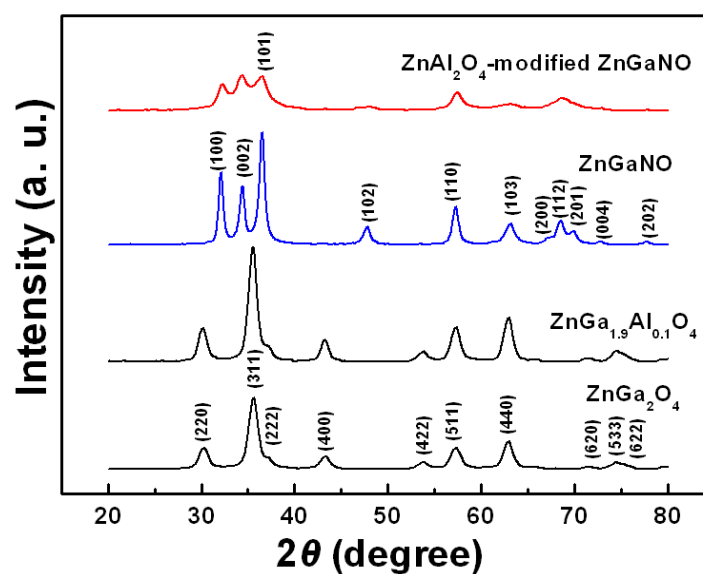


Fig.S7. XRD patterns for ZnGa_2O_4 (obtained by hydrothermal treatment of the product from room-temperature ion exchange of NaGaO_2 and $\text{Zn}(\text{CH}_3\text{COO})_2$), $\text{ZnGa}_{1.9}\text{Al}_{0.1}\text{O}_4$ (obtained by hydrothermal treatment of the product from room-temperature ion exchange of $\text{NaGa}_{0.95}\text{Al}_{0.05}\text{O}_2$ and $\text{Zn}(\text{CH}_3\text{COO})_2$), and their corresponding nitriding products: ZnGaNO and ZnAl_2O_4 -modified ZnGaNO .

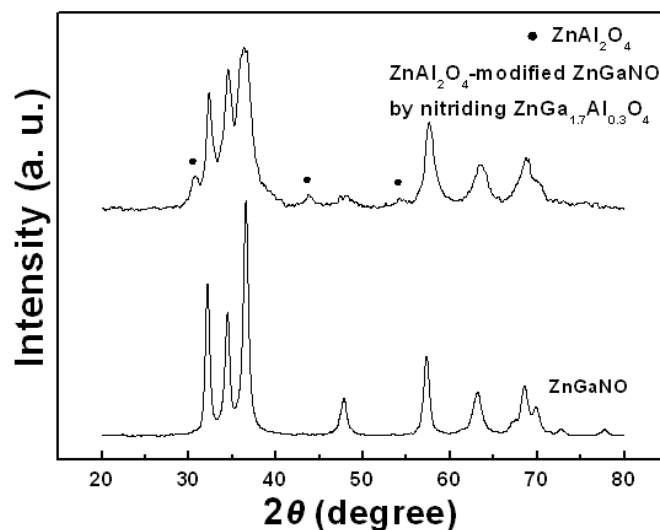


Fig. S8 XRD patterns for the ZnAl_2O_4 -modified ZnGaNO (obtained by nitriding the $\text{ZnGa}_{1.7}\text{Al}_{0.3}\text{O}_4$) and ZnGaNO (obtained by nitriding the ZnGa_2O_4).

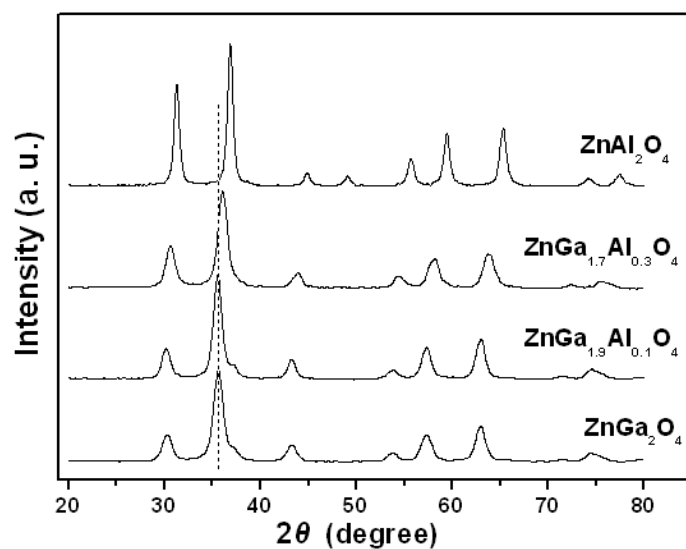


Fig. S9 XRD patterns for the ZnGa_2O_4 , $\text{ZnGa}_{1-x}\text{Al}_x\text{O}_4$ ($x=0.1, 0.3$) and ZnAl_2O_4 .

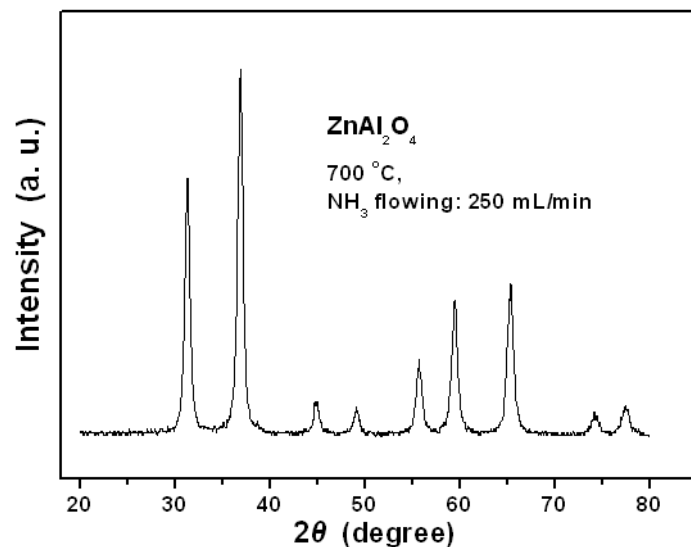


Fig. S10 XRD pattern for ZnAl_2O_4 obtained by heating a product from ion exchange of NaAlO_2 and $\text{Zn}(\text{CH}_3\text{COO})_2$, at $700\text{ }^\circ\text{C}$ under 250 mL min^{-1} of NH_3 flowing. The XRD pattern is in good agreement with JCPDS No 74-1136, indicating that the single-phase ZnAl_2O_4 formed.

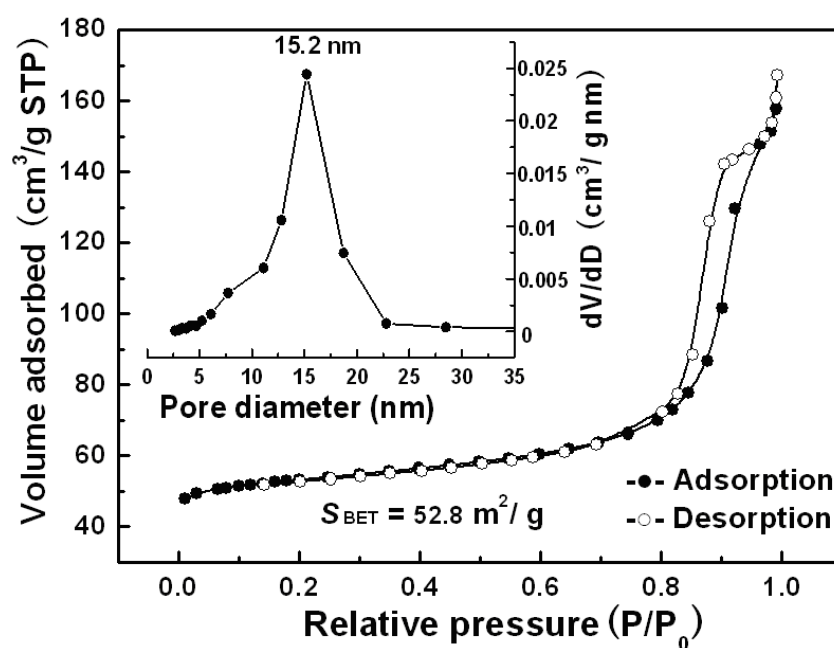


Fig.S11. Nitrogen absorption-desorption isotherms and pore-size distribution (inset) of ZnAl_2O_4 -modified ZnGaNO

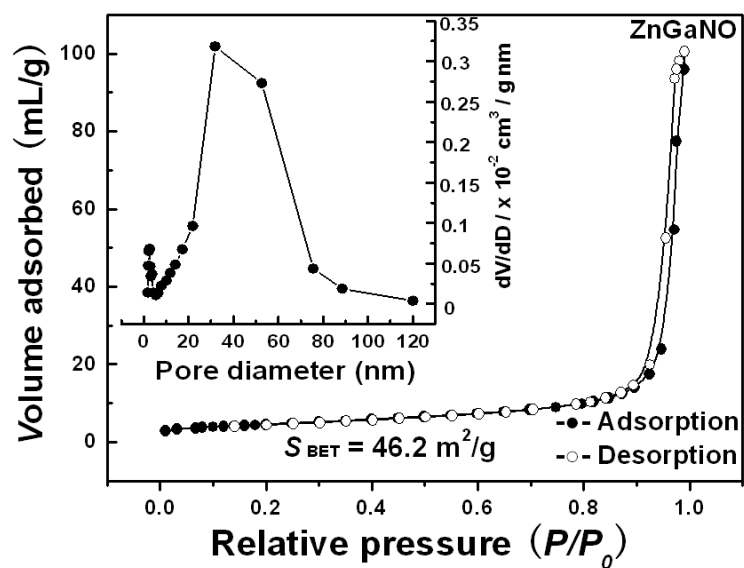


Fig. S12 Nitrogen absorption-desorption isotherms and pore-size distribution (inset) for ZnGaNO obtained by nitriding ZnGa₂O₄ at 700 °C.

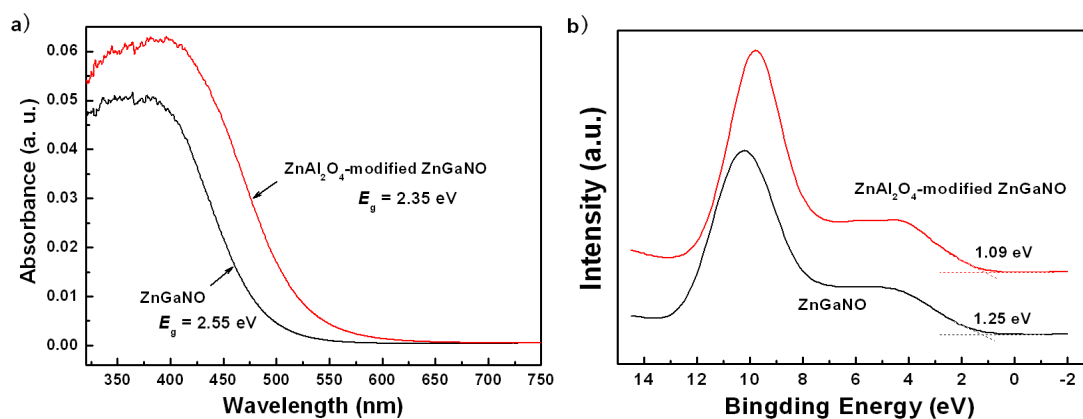


Fig.S13. a) UV-vis absorption spectra and b) VB XPS spectra for the ZnGaNO and ZnAl₂O₄-modified ZnGaNO. The band gap of ZnAl₂O₄ is about 4.5 eV.

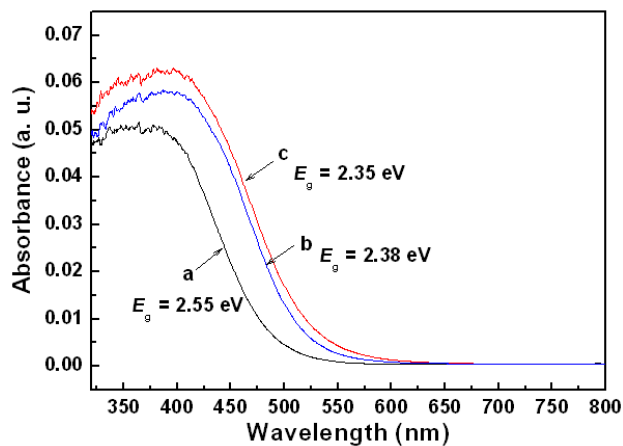


Fig. S14 UV-vis absorption spectra: ZnGaNO (curve a), ZnAl₂O₄-modified ZnGaNO obtained by nitriding ZnGa_{1.7}Al_{0.3}O₄ (curve b), and ZnAl₂O₄-modified ZnGaNO obtained by nitriding ZnGa_{1.9}Al_{0.1}O₄ (curve c).

Compared with the ZnAl_2O_4 -modified ZnGaNO obtained by nitriding $\text{ZnGa}_{1.9}\text{Al}_{0.1}\text{O}_4$, the UV-Vis absorption spectrum of the ZnAl_2O_4 -modified ZnGaNO obtained by nitriding $\text{ZnGa}_{1.7}\text{Al}_{0.3}\text{O}_4$ exhibited a blue shift of about 6 nm (Figure S15). This small shift probably resulted from the ZnAl_2O_4 content in the ZnGaNO obtained by nitriding $\text{ZnGa}_{1.7}\text{Al}_{0.3}\text{O}_4$ increases, which lead to the relative Zn content in ZnGaNO decreases. This also indicates that the high Al content in $\text{Zn}(\text{Ga}_{1-x}\text{Al}_x)_2\text{O}_4$ precursor is not beneficial for improving the Zn content in the ZnGaNO product.

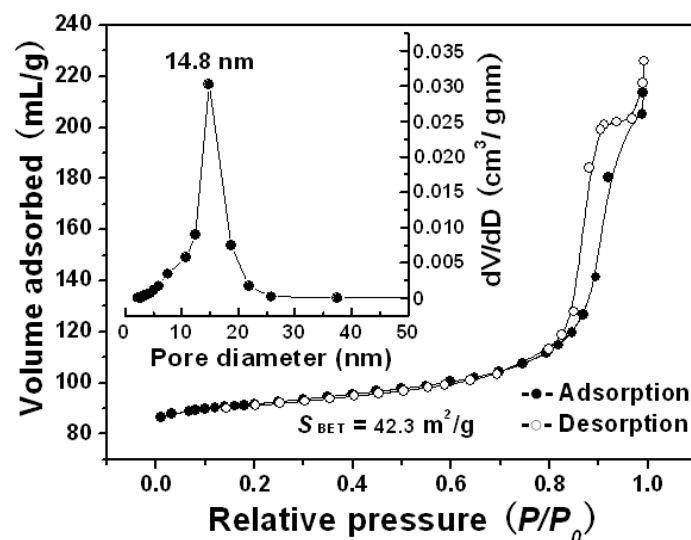


Fig. S15 Nitrogen adsorption-desorption isotherms and pore-size distribution (inset) for ZnAl_2O_4 -modified ZnGaNO obtained by nitriding $\text{ZnGa}_{1.7}\text{Al}_{0.3}\text{O}_4$.

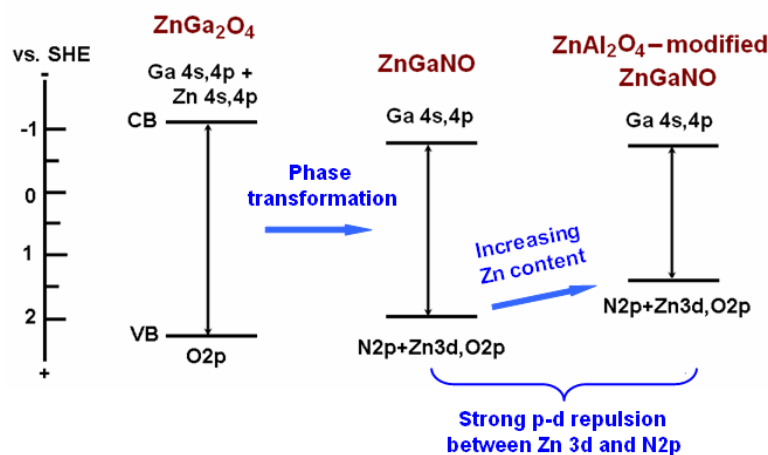


Fig. S16 Schematic band structures for the ZnGa_2O_4 , ZnGaNO and ZnAl_2O_4 -modified ZnGaNO

For the semiconducting ZnGa_2O_4 with a band gap of 4.4 eV, the valence band was mainly composed of the $\text{O}2\text{p}$ orbitals and the conduction band was formed by hybridization of $\text{Ga } 4\text{s}, 4\text{p}$ and $\text{Zn } 4\text{s}, 4\text{p}$ orbitals. By nitriding treatment of ZnGa_2O_4 , the ZnGaNO solid solution with a band gap of about 2.55 eV can be obtained. The valence band edge of ZnGaNO primarily derives from $\text{Zn } 3\text{d}$, $\text{N } 2\text{p}$ and $\text{O } 2\text{p}$ orbitals and the conduction band edge from $\text{Ga } 4\text{s}, 4\text{p}$ orbitals. In particular, the presence of $\text{Zn}3\text{d}$ and $\text{N}2\text{p}$ electrons in the upper valence band provides p-d repulsion for the

valence band maximum, which results in narrowing the band gap. Therefore, increasing the Zn content in the ZnGaNO can increase the valence band by the strong p-d repulsion between Zn 3d and N 2p. ZnAl₂O₄-modified ZnGaNO was obtained by nitriding the Zn(Ga_{1-x}Al_x)₂O₄. The phase separation occurred during the nitriding, that is, the ZnAl₂O₄ in situ formed during the phase transformation from ZnGa₂O₄ to ZnGaNO. The formation of the ZnAl₂O₄ can prevent the Zn volatilization due to its chemical inertness. Therefore, the ZnAl₂O₄-modified ZnGaNO has high Zn content, thus having the small band gap.

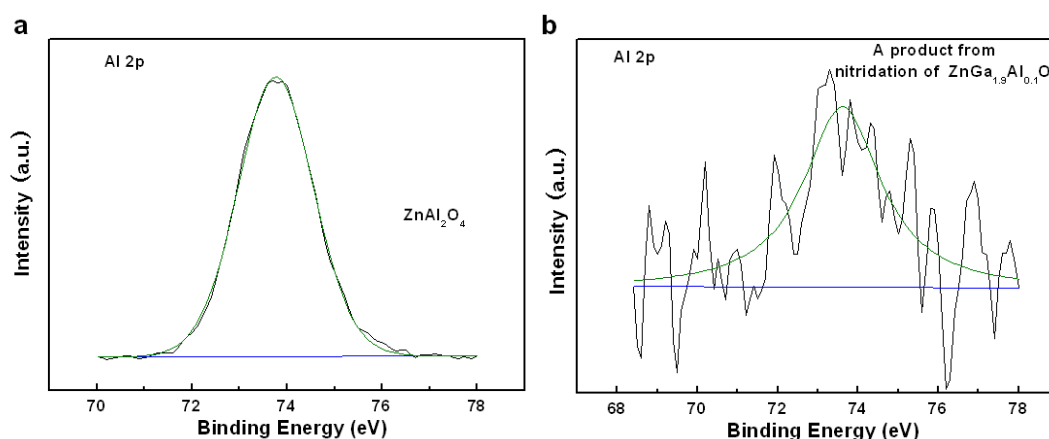


Fig. S17 Al2p XPS spectra: a) ZnAl₂O₄, b) ZnAl₂O₄-modified ZnGaNO (obtained by nitriding ZnGa_{1.9}Al_{0.1}O₄). The peak at 73.46 eV for Al2p of ZnAl₂O₄ is basically consistent with the Al2p of the product from nitriding of ZnGa_{1.9}Al_{0.1}O₄, indicating that the ZnAl₂O₄ occurred during the nitriding ZnGa_{1.9}Al_{0.1}O₄.

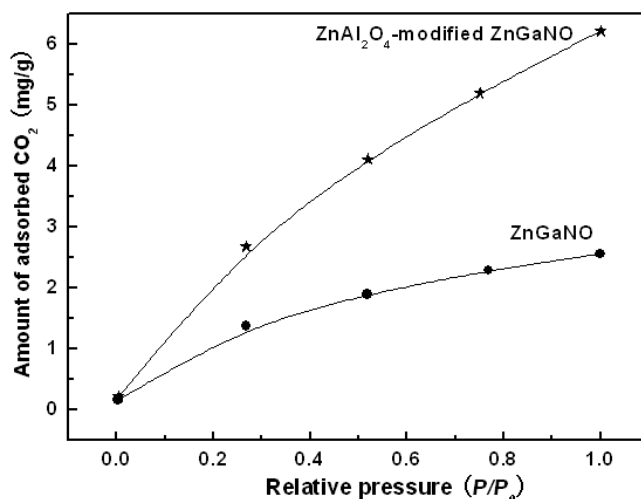


Fig. S18 CO₂ absorption isotherms for ZnGaNO and ZnAl₂O₄-modified ZnGaNO.

The amount of physisorbed CO₂ was determined by a BET method at 0 °C. The ZnGaNO and ZnAl₂O₄-modified ZnGaNO were pretreated at 200 °C for 2h under flowing N₂ gas for clearing the surface. The CO₂ adsorption was carried out on a surface area analyzer (Micrometrics Co., USA). The CO₂ was firstly adsorbed on the surface of powder samples at 0 °C by a standard adsorption procedure same to N₂ adsorption used in the specific surface area test (first adsorption).

After reaching the gas adsorption equilibrium, the powder sample was vacuum-treated. After that, the CO₂ adsorption was again carried out (second adsorption). In the second CO₂ adsorption test, the powder sample mainly exhibited a physisorption process because the chemisorbed CO₂ in the first adsorption test does not be removed by vacuum-treating, but the physisorbed CO₂ does. Therefore, the amount of physisorbed CO₂ was determined using the second adsorption test.

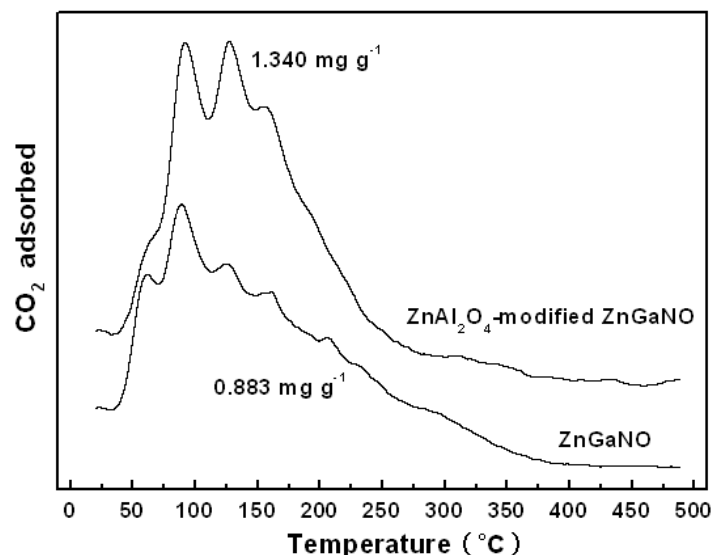


Fig. S19 CO₂-TPD profiles of ZnGaNO and ZnAl₂O₄-modified ZnGaNO.

In a typical CO₂-TPD experiment, the sample was activated at 500 °C for 2 h prior to the adsorption of CO₂ at 25 °C. After purging the physically adsorbed CO₂ at 25 °C, the sample was heated to 500 °C at a rate of 8 °C min⁻¹.

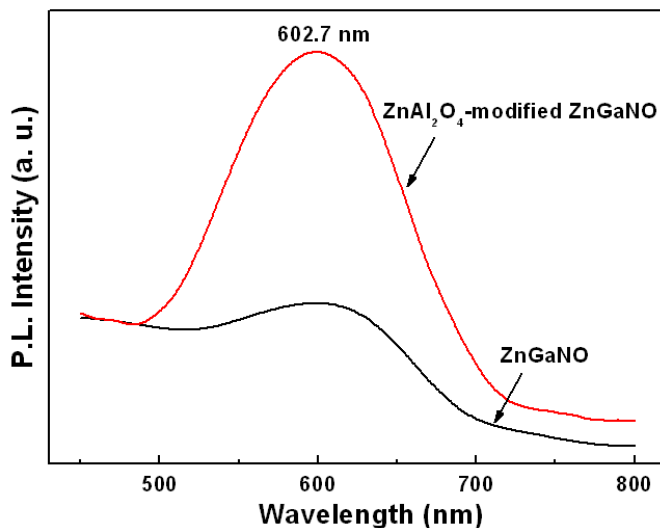


Fig. S20 Room temperature PL spectra for the as-prepared ZnGaNO and ZnAl₂O₄-modified ZnGaNO. Excitation at 380 nm.

In a previous study [M. Yashima, K. Maeda, K. Teramura, T. Takata, K. Domen, *Chem. Phys. Lett.* 2005, 416, 225], it was confirmed that the ZnGaNO solid solution exhibits photoluminescence (PL) resulting from the recombination of photogenerated electrons and holes.

The PL process is largely governed by the presence of surface vacancies and defects since they act as recombination centers for photogenerated electrons and holes. In our case, the photoluminescence (PL) spectroscopy was obtained by using the Cary eclipse fluorescence spectrophotometer. The ZnGaNO and ZnAl₂O₄-modified ZnGaNO exhibit a PL band at around 602 nm upon photoexcitation at 380 nm, as shown in Fig.S14. It can be seen that the intensity of the PL band of the ZnAl₂O₄-modified ZnGaNO is higher than that of the ZnGaNO, suggesting that the recombination centers of the electrons and holes were increased, probably due to the Zn²⁺ or Ga³⁺ defects from the ZnAl₂O₄ phase separation during the nitriding ZnGa_{1.9}Al_{0.1}O₄. For the ZnAl₂O₄-modified ZnGaNO, the ZnAl₂O₄ occurred during the nitridation of ZnGa_{1.9}Al_{0.1}O₄. This phase separation process may increase the formation of some defects such as Ga³⁺ and Zn²⁺ vacancies, which usually are Lewis base sites. CO₂ is adsorbed on the base site easily, and then the conformation of a linear CO₂ molecule undergoes a great change. The adsorption of CO₂ contributes to the photocatalytic reduction of CO₂.

The water adsorption on these as-prepared samples was also investigated by weighing method. These weighed as-prepared samples were spread on the surface of glass plate with about 4.2 cm², and put into a closed desiccator. The water adsorption was performed under 75% humidity at 35 °C for 24 h. These samples were weighed again after water adsorption. The amount of increase in weight is the amount of water adsorbed on the sample. The amount of water adsorbed on the ZnAl₂O₄-modified ZnGaNO was determined to be 0.212 g/g, which is about 4 times as high as the adsorbed amount of 0.056 g/g for the ZnGaNO, probably due to the mesoporous structure and improved surface area.

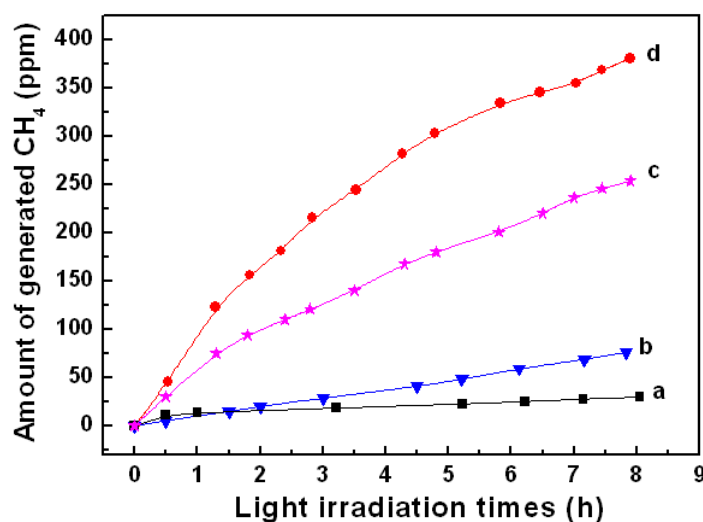


Fig. S21 CH₄ generation over N-doped TiO₂ (curve a), ZnGaNO (curve b), ZnAl₂O₄-modified ZnGaNO obtained by nitriding ZnGa_{1.7}Al_{0.3}O₄ (curve c), and ZnAl₂O₄-modified ZnGaNO obtained by nitriding ZnGa_{1.9}Al_{0.1}O₄ (curve d), as a function of irradiation time. The all catalysts were modified by loading 0.5 wt.% Pt as co-catalyst.

Compared with the ZnAl₂O₄-modified ZnGaNO obtained by nitriding ZnGa_{1.9}Al_{0.1}O₄, the photocatalytic activity in photoreduction CO₂ for ZnAl₂O₄-modified ZnGaNO obtained by nitriding ZnGa_{1.7}Al_{0.3}O₄ decreased (Figure S17). The ZnAl₂O₄-modified mesoporous ZnGaNO obtained by nitriding ZnGa_{1.7}Al_{0.3}O₄ exhibited a CH₄ generation rate of 49.7 ppm h⁻¹ during the

first hour under visible light illumination. The specific surface area of the ZnAl_2O_4 -modified ZnGaNO obtained by nitriding $\text{ZnGa}_{1.7}\text{Al}_{0.3}\text{O}_4$ ($42.3 \text{ m}^2/\text{g}$) (Figure S16) is lightly lower than that of the ZnAl_2O_4 -modified ZnGaNO obtained by nitriding $\text{ZnGa}_{1.9}\text{Al}_{0.1}\text{O}_4$ ($52.8 \text{ m}^2/\text{g}$), however, the ZnAl_2O_4 content in the former is higher than that in the later. This means that the more ZnAl_2O_4 dispersed on the surface of the ZnAl_2O_4 -modified ZnGaNO obtained by nitriding $\text{ZnGa}_{1.7}\text{Al}_{0.3}\text{O}_4$, which decreased the reaction sites, thus decreased photocatalytic activity.

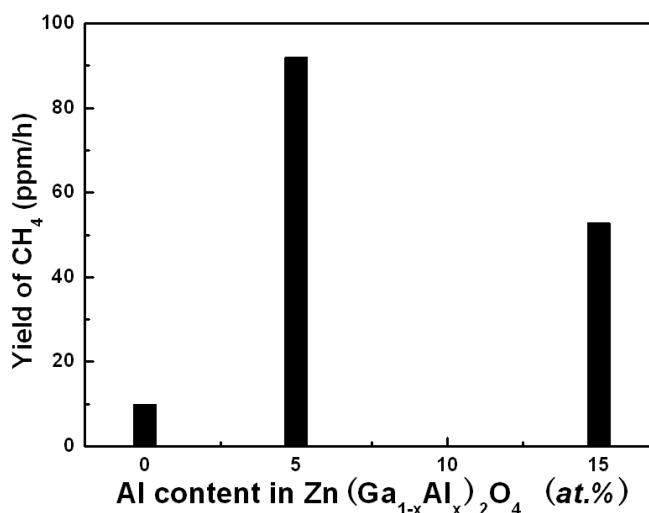


Fig. S22 CH_4 generation rate over the ZnGaNO (0 at. % Al), ZnAl_2O_4 -modified ZnGaNO obtained by nitriding the $\text{ZnGa}_{1.9}\text{Al}_{0.1}\text{O}_4$ (5 at.% Al) and ZnAl_2O_4 -modified ZnGaNO obtained by nitriding the $\text{ZnGa}_{1.7}\text{Al}_{0.3}\text{O}_4$ (15 at.% Al). The all catalysts were modified by loading 0.5 wt.% Pt as co-catalyst. Apparently, the ZnAl_2O_4 -modified ZnGaNO obtained by nitriding the $\text{ZnGa}_{1.9}\text{Al}_{0.1}\text{O}_4$ exhibited the best photocatalytic activity.

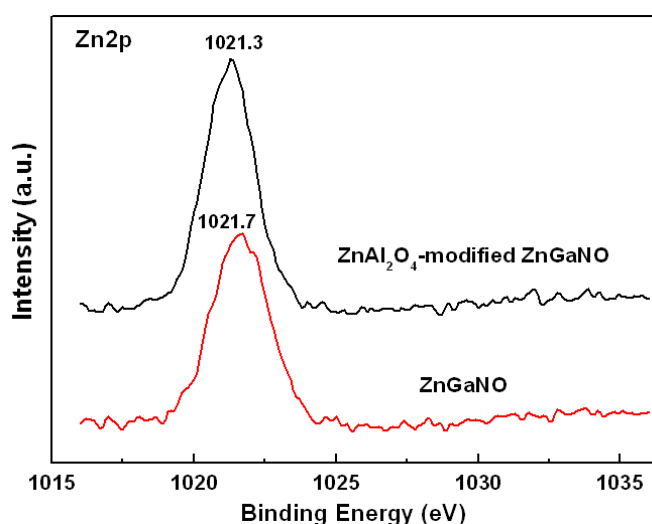


Fig. S23 $\text{Zn}2\text{p}$ XPS spectra for ZnGaNO and ZnAl_2O_4 -modified ZnGaNO .

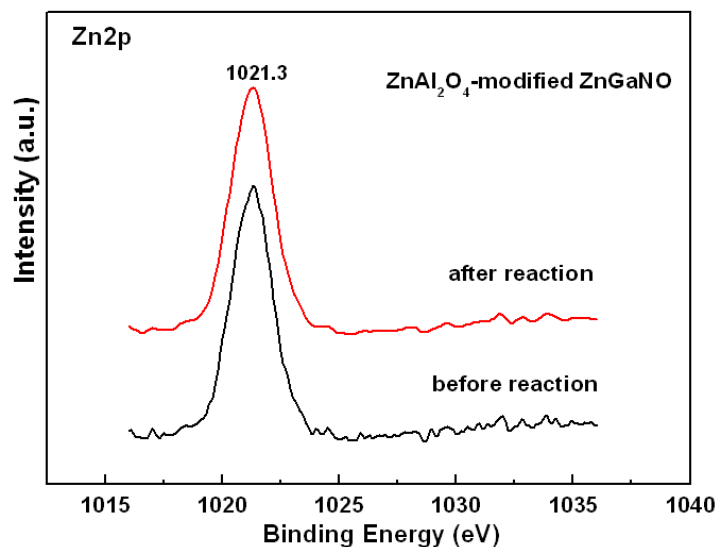


Fig. S24 Zn2p XPS spectra for ZnAl₂O₄-modified ZnGaNO before reaction and after reaction.

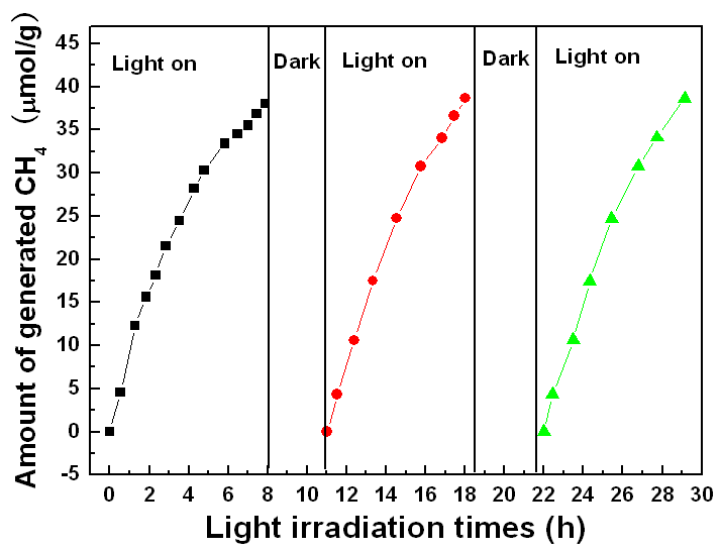


Fig. S25 CH₄ generation over ZnAl₂O₄-modified ZnGaNO in three reaction cycles as a function of irradiation time.

In the three reaction cycles, the CH₄ generation rate in second reaction cycle is 7.4 μmol g⁻¹h⁻¹, which is about 19% lower than that in the first reaction cycle. However, the CH₄ generation rate in third reaction cycle is similar to that in the second reaction cycle to be 7.2 μmol g⁻¹h⁻¹. This indicates that the photocatalytic performance of ZnAl₂O₄-modified ZnGaNO is stable.

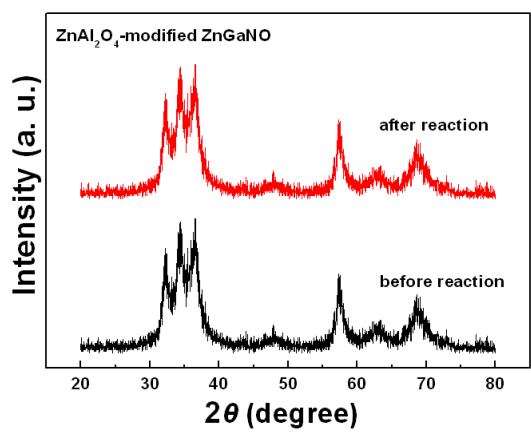


Fig. S26 XRD patterns for ZnAl₂O₄-modified ZnGaNO before reaction and after reaction.